

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Inventor..... John T. Moore et al.
Assignee..... Micron Technology, Inc.
priority Examiner N. Drew Richards
priority Group Art Unit 2815
Customer No. 021567
Attorney Docket No. MI22-2463
Title: (As Amended) Semiconductor Wafer Assemblies Comprising Photoresist Over
Silicon Nitride Materials

PRELIMINARY AMENDMENT

To: MS Patent Application
Commissioner for Patents
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AMENDMENTS

Introductory Comments

This preliminary amendment accompanies filing of a continuation application.